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# SiPM Geiger discharge for high intensity light registration

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## Measurement setup with 40ps laser 405nm, digital scope 2GHz with light intensity control



#### Signals from stand alone cell

### Fixed overvoltage $\Delta U=1.65V$ , different light intensity



We have developed a SPICE model of Geiger discharge propagation

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# Single cell pulses for different intensity light but for fixed overvoltage. MEPHI cell (100x100µm<sup>2</sup>)



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Very small difference in pulse shapes for different light intensities

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### Single cell pulses for different intensity light. FBK cell

U=38V



U-U<sub>breakdown</sub> doesn't change Q increases due to increasing of  $C_{fast}+C_{slow}$ 

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△U changes with intensity – voltage drops on cell p-n-junction below U<sub>breakdown</sub>

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for Geiger mode operation in oversaturation conditions (>>1 phe/cell) depends on light intensity due to extremely fast developing of the Geiger discharge

•Depending on SiPM cell construction (technology used) high light intensity may affect cell capacity or/and voltage drop on cell pn-junction below U<sub>breakdown</sub>

•The lower overvoltage the grater a shift in start of the SiPM cell restoration

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